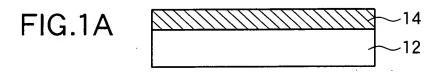
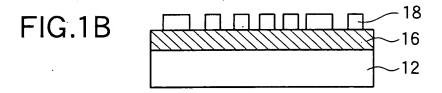
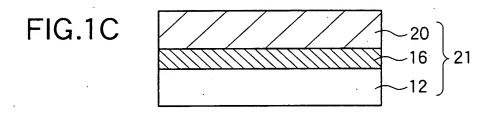
Inventor: Takehiko MAKITA et al.
Attorney Docket No.: 31869-198826
Title: SURFACE TREATMENT METHOD FOR
A COMPOUND SEMICONDUCTOR LAYER
AND METHOD OF FABRICATION OF A
SEMI8CONDUCTOR DEVICE
Page 1 of 9







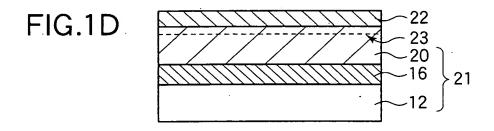


FIG.2A

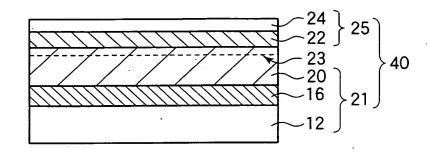


FIG.2B

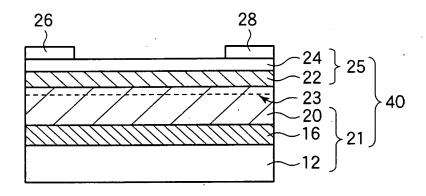
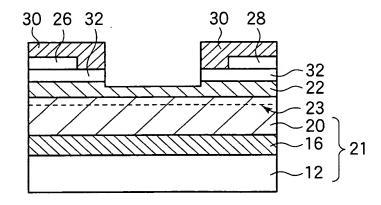


FIG.2C



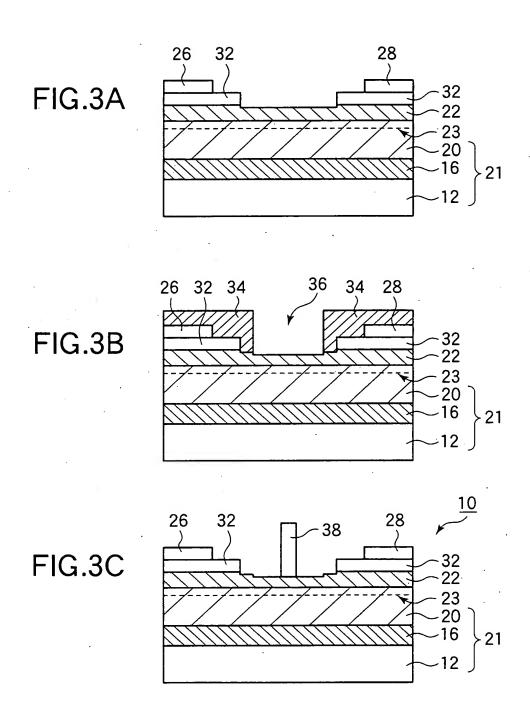
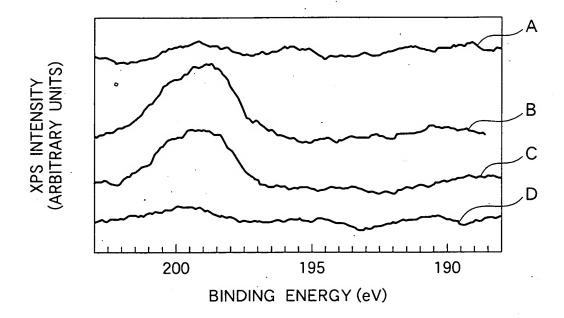
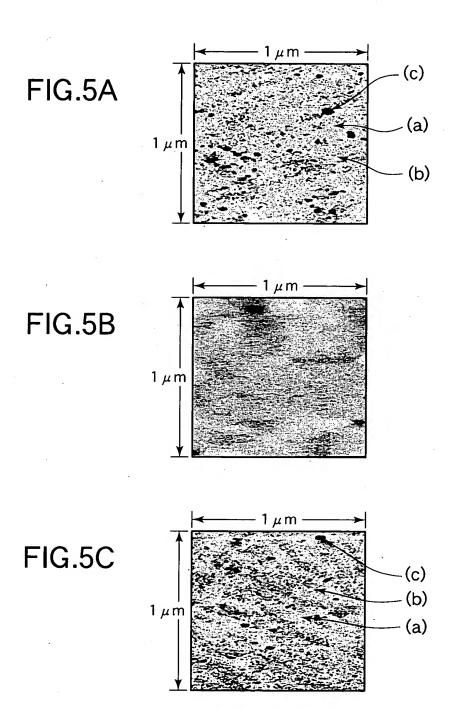


FIG.4





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Attorney Docket No.: 31869-198826
Title: SURFACE TREATMENT METHOD FOR
A COMPOUND SEMICONDUCTOR LAYER
AND METHOD OF FABRICATION OF A
SEMI8CONDUCTOR DEVICE
Page 6 of 9



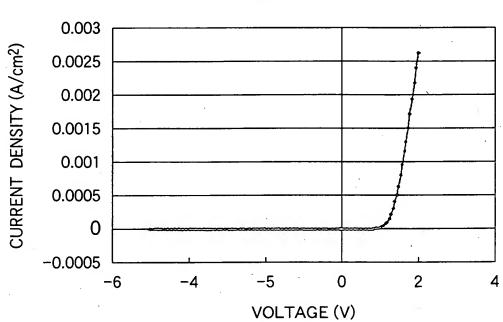


FIG.6B

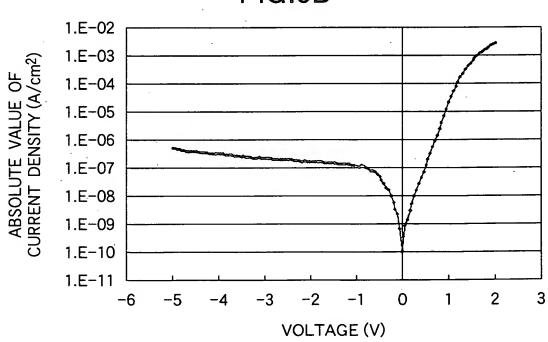
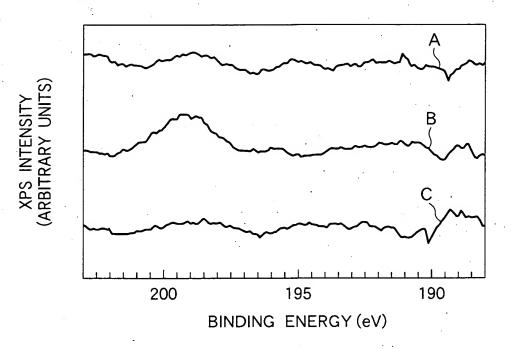
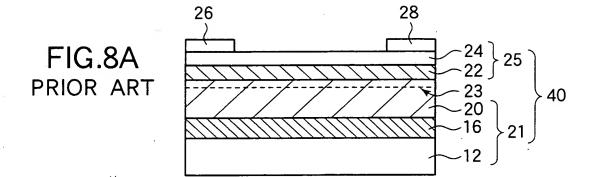
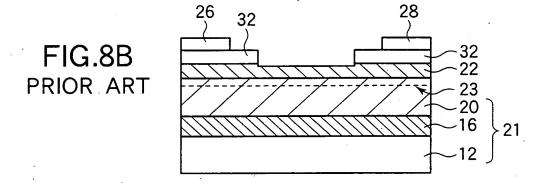


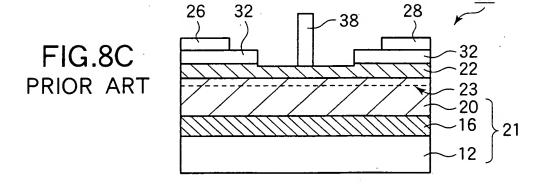
FIG.7



Inventor: Takehiko MAKITA et al.
Attorney Docket No.: 31869-198826
Title: SURFACE TREATMENT METHOD FOR
A COMPOUND SEMICONDUCTOR LAYER
AND METHOD OF FABRICATION OF A
SEMISCONDUCTOR DEVICE
Page 8 of 9







Inventor: Takehiko MAKITA et al.
Attorney Docket No.: 31869-198826
Title: SURFACE TREATMENT METHOD FOR A COMPOUND SEMICONDUCTOR LAYER
AND METHOD OF FABRICATION OF A SEMI8CONDUCTOR DEVICE
Page 9 of 9

FIG.9 PRIOR ART

